



MAR 28 2006

Appln. No.: 10/686,893
Amendment Dated March 20, 2006
Reply to Office Action of December 20, 2005

YAO-3990US3

Appln. No.: 10/686,893
Applicant: Hidetoshi Ishida, et al.
Filed: October 16, 2003
Title: ETCHANT AND METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE
USING THE SAME
TC/A.U.: 2823
Examiner: Quovaunda Jefferson
Confirmation No.: 8582
Docket No.: YAO-3990US3

AMENDMENT UNDER 37 C.F.R. § 1.116

Expedited Procedure

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated **December 20, 2005**, please amend the above identified application as follows:

- ☒ **Amendments to the Claims** are reflected in the listing of claims which begins on page **2** of this paper.
- ☒ **Remarks/Arguments** begin on page **3** of this paper.

ENTERED
By
RCE
4/24/06
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